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	RAMAN SPECTROSCOPY DEVICE AND	CPC G01N 21/658	
<u> </u>	METHOD THE DELFOR	See annlication file for complete search history	
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	Kingston (CA)	U.S. PATENT DOCUMENTS	
: <u>'</u>	(72) Inventors: Hannah Bacon, Toronto (CA);	6,558,956 B1 5/2003 Carron et al.	
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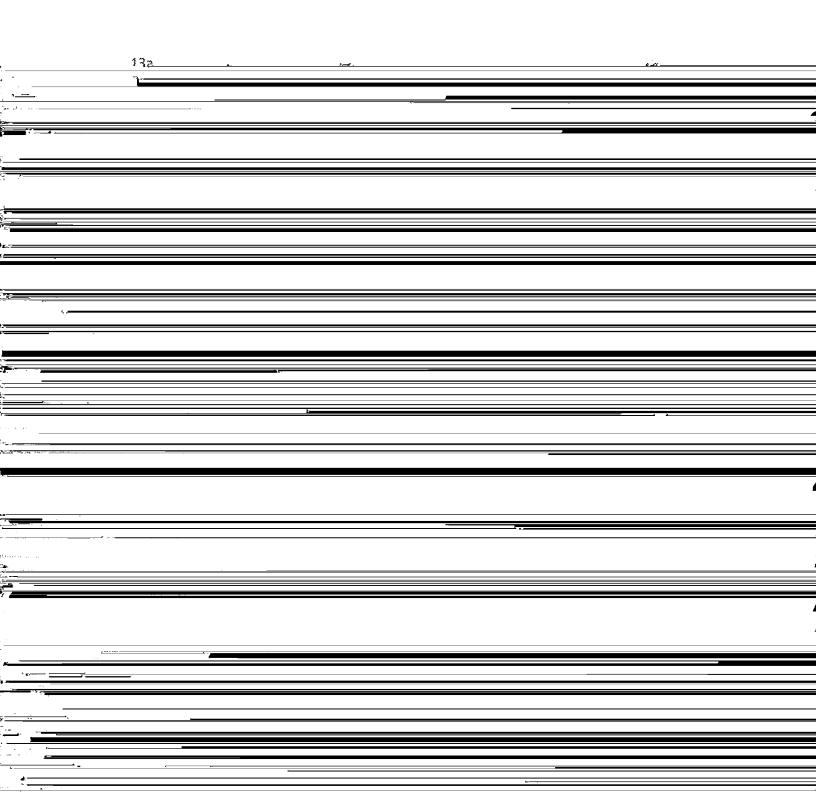
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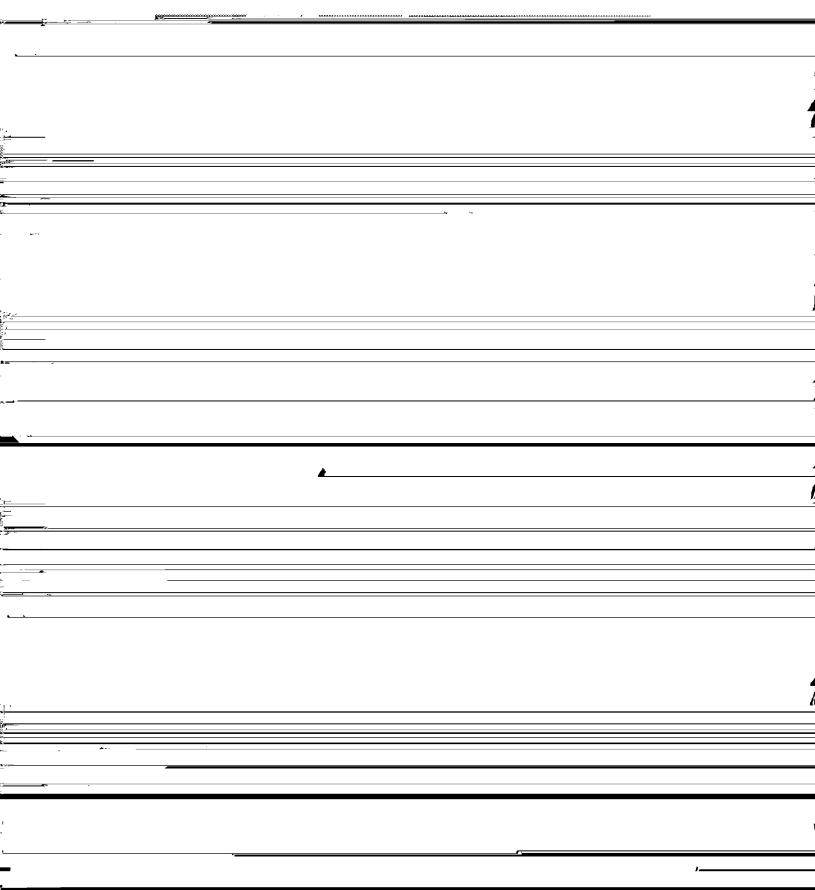
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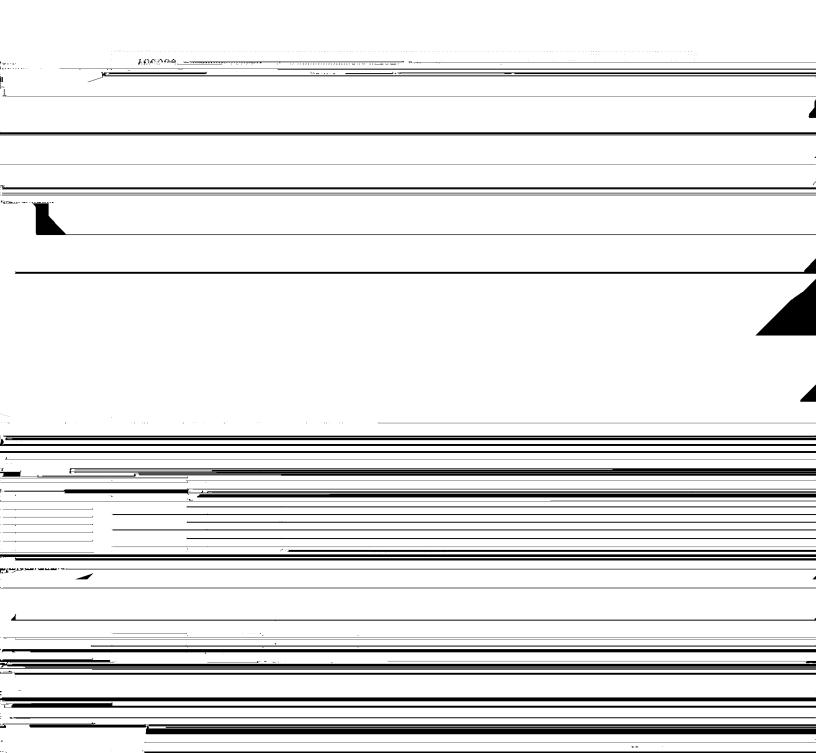
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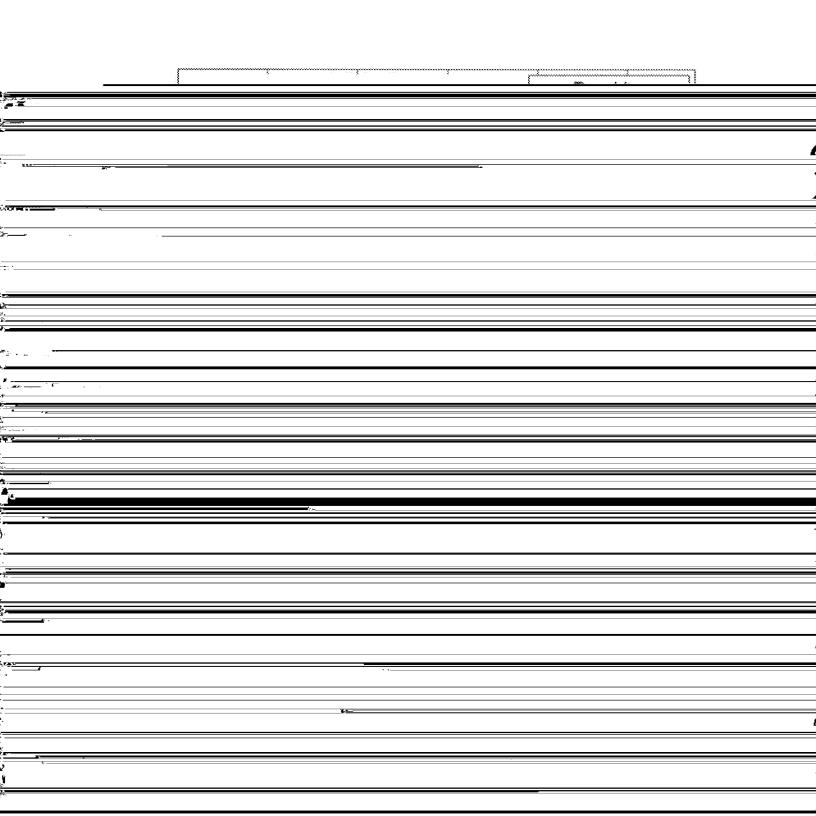


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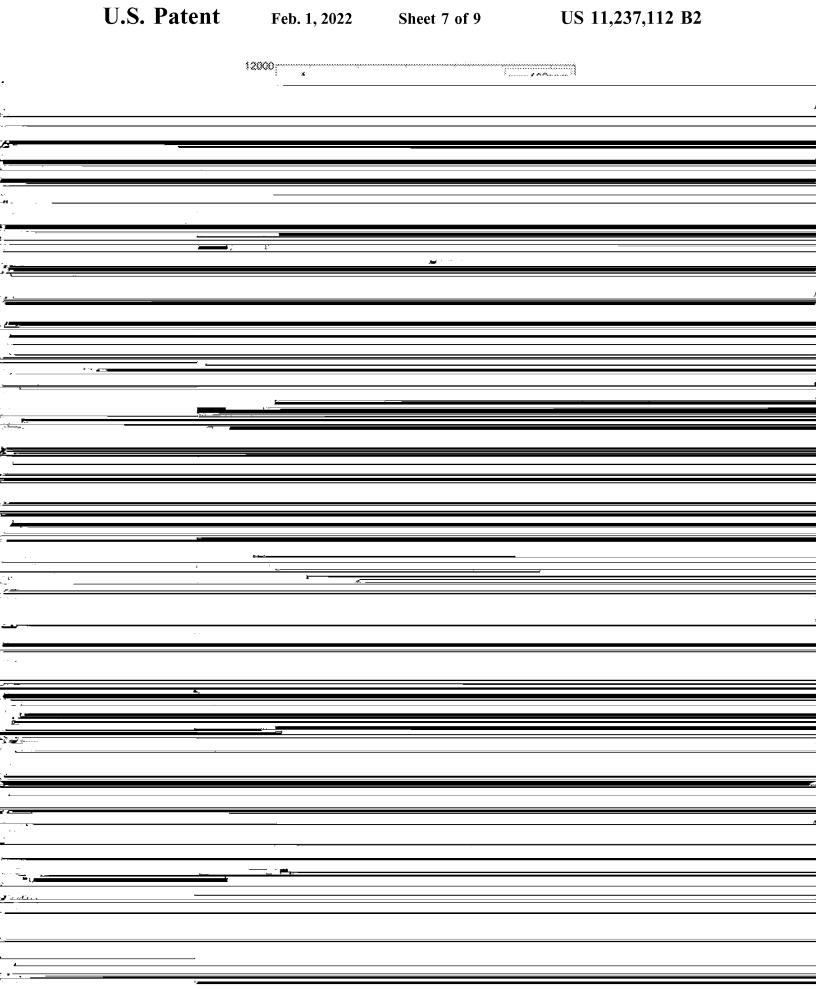






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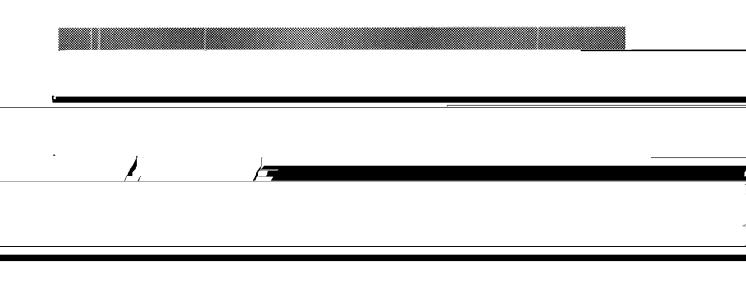




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# RECONFIGURABLE SURFACE ENHANCED RAMAN SPECTROSCOPY DEVICE AND METHOD THEREFOR

This application is a 371 of International Application No. PCT/CA2017/050931 flied on Aug. 4, 2017, and claims the benefit of the filing date of U.S. Application No. 62/373,537 filed on Aug. 11, 2016, the contents of which are incorpo-

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substrate in a spaced relationship such that a detection site is formed along edges and/or between opposing edges of the microelectrodes; and a nanoparticle structure comprising a plurality of metallic nanoparticles disposed in the detection site

Assembly of the nanoparticle structure may be directed by an electric field between the at least two microelectrodes. The electric field may comprise an AC electric field. The electric field may comprise an AC electric field with a DC.

#### FIELD

This invention relates to surface enhanced Raman spectroscopy (SERS). More specifically, this invention relates to a highly sensitive SERS device that is simple and cost <sup>15</sup> effective to produce, and re-usable.

field. The electric field may comprise an electrostatic field. The nanoparticle structure may be a branched, clustered, aggregated, fractal, and/or dendritic structure. In one embodiment, the nanoparticle structure is a dendritic structure.

The nanoparticles may be functionalized. The functionalized nanoparticles may include a surface modification. The

posed on the substrate in a spaced relationship such that a detection site is formed along edges and/or between opposing edges of the microelectrodes; disposing a plurality of metallic nanoparticles on the detection site under a condition

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FIGS. 6A, 6B, and 6C show results for melamine, cocaine, and thiram respectively, using passive surface adsorption of the analytes; all spectra represent averages from three different locations on the SERS device.

of the device are arranged such that a 3-D electrode con-

trokinetic deposition comprises applying an alternating cur-

electrode(s) to be moved relative to the substrate electrodes. In another example, one or more electrodes may be disposed on a first substrate, and one or more electrodes may be 5 disposed on a second substrate, and the first and second substrates arranged face-to-face (e.g., substantially co-planar, or at a selected angle) such that a 3-D electrode configuration is produced. The two or more microelectrodes may be deposited in their final form, or they may be formed, 10 or their shape and/or size and/or spacing may be adjusted, by subsequently removing metal (e.g., by using a mechanical, chemical, laser, and/or micromachining technique). For example, the shape, size, and or spacing of the two or more microelectrodes may be carried out to adjust or tailor the size 15 or shape of the detection site. Surface preparation of the solid substrate may be employed as necessary prior to depositing the metal, as would be apparent to one or ordinary skill in the art, to enable or enhance adhesion of the metal to the solid substrate.

As used herein, the terms "nanoparticle structure" and "nanoparture tructure" refer to a structure that is seemed or

etc., to the two or more microelectrodes to generate an electric field between them (i.e., across the detection site). In some embodiments a direct current (DC) offset may also be applied to the two or more microelectrodes. In some embodiments a DC electric field or an electrostatic field may be applied to the two or more microelectrodes. The electric field acts on the nanoparticles to influence, induce, or direct formation of the nanoparticle structure, including, in some embodiments, the formation of branches, clusters and/or dendrites. The nanoparticle structure may be "active", which refers to the fact that characteristics of the structure, including the formation and extent of branches, clusters, and/or dendrites, may be controlled, tuned, and/or optimized during deposition as well as during analysis of a sample (i.e., dynamically) by providing and optionally controlling an electric field across an electrode gap. For example, an electric field may be controlled by adjusting one or more parameters (e.g., voltage, current, frequency, shape of waveform, duty cycle) of the AC current, and optionally the DC affect to thereby adjust the electric field. Describe above that

1	electrodes 12a, 12b, 13a, 13b (i.e., a quadrupolar micro-	Metallic dendritic nanostructures have been produced
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urable. In this feature, embodiments contrast sharply with prior devices having soft substrates (e.g., paper in some prior devices). Because of the solid substrates, the dendrites may be removed (e.g., by washing with a simple surfactant **10** 

layer of chrome was used to improve the adhesion of the deposited Au layer (100 nm thickness) to the silicon substrate.

Analyte Sample Preparation
R6G was dissolved in methanol at a stock concentration

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	Raman spectra were background-corrected through polyno-	standard photolithographic techniques. Therefore, this
	mial subtraction, and noise was reduced with a Savitsky-	method of enhancing dendrite growth provides embodi-
	Golay filter. Optimization of Electrokinetic Nanoparticle Deposition	ments with small microelectrode gaps while avoiding the need for specialized production techniques or equipment,
	Optimization_experiments_were_conducted_across_a wide	need for specialized production techniques or equipment,
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dendrite formation was found to include a frequency of about 1-100 Hz, and a voltage of about 2.5-3.5 V peak-topeak (i.e., an electric field intensity of about  $1.5-2.1\times10^5~10~V/m$ ). For example, in one experiment, extended dendrites

FIG. 3 shows the results of optimization experiments conducted with embodiments using AgNPs and AuNPs, where SERS performance is quantified through the intensity of 2 keV 2004 (1360 cm<sup>-1</sup>) in the Raman spectrum of

cocaine, and (3) thiram. Melamine is a nitroger	nous indus-
trial chemical used in resin production and fertili	
<u></u>	insoluble

r³) would only be capable of attracting large biological objects, such as bacteria and viruses. In the presence of a doudritic\_nonomertials attracture, however, this corpobility

crystals in the kidney, leading to renal failure. Because of its high nitrogen content (66.7% by mass), melamine has been 5 added to dairy products, infant formulations, or pet food, in order to boost the apparent protein content. Such use has resulted in the deaths of hundreds of cats and dogs in the United States in 2007, and the hospitalization of over 50,000

may be extended to smaller objects, such as biomolecules (e.g., proteins, DNA). To demonstrate the principal of active analyte concentration amplification here, the technique is applied to the detection of BSA, an abundant plasma protein, as well as *E. coli* K12, a Gram negative rod-shaped bacterium

graphene-coated dendrites (upper trace). Overall, 2- to  $5-f\Omega ld$  SFRS signal enhancement was observed

electrode configuration is provided and a detection site is formed along edges and/or between opposing edges

#### INCORPORATION BY REFERENCE

All cited publications are incorporated herein by reference in their entirety.

#### **EQUIVALENTS**

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of the first and second electrodes; and disposing a plurality of metallic nanoparticles on the detection site under a condition that induces, directs, or influences assembly of the metallic nanoparticles into a nanoparticle structure in the detection site along edges and/or between opposing edges of the first and second electrodes in the absence of an analyte;

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**26**. The method of claim **9**, wherein the second electrode is disposed on the first non-electrically conductive substrate; wherein a 2-D electrode configuration is provided.

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